Multi-Material 3D Printing of Functional Ceramic Devices

Subjects: Engineering, Manufacturing | Chemistry, Applied Contributor: Hui Chen , Liang Guo , Wenbo Zhu , Chunlai Li

As an emerging technology, multi-material 3D printing offers increased complexity and greater freedom in the design of functional ceramic devices because of its unique ability to directly construct arbitrary 3D parts that incorporate multiple material constituents without an intricate process or expensive tools.

multi-material 3D printing functional ceramic devices capacitors multilayer substrates

microstrip antennas

1. Introduction

Compared with structural ceramics, functional ceramic devices are characterized by their detection, transformation, coupling, transmission, processing, and storage of information (i.e., electrical, magnetic, optical, acoustic, thermal, force, and biological ^[1]), and they have been used in numerous fields (i.e., aviation, automobile, integrated circuit, communication, medical, and energy) ^[2]. Most functional ceramic devices, such as multilayer ceramic capacitors, multilayer ceramic substrates, filters, chip antennas, power dividers, and duplexers, can be fabricated by a high-temperature cofired ceramic (HTCC) process or low-temperature cofired ceramic (LTCC) process ^{[3][4][5][6][7][8]}. These processes require multiple steps: (1) material preparation for ceramic tapes and functional pastes, (2) punching of the green tapes for via formation, (3) filling and metalizing for vertical conductors and horizon circuitries formation, (4) stacking and laminating for 3D ceramic green body formation that can be maintained as an array or cut into individual products, (5) cofiring, and (6) post processing including nickel plating, brazing, and gold plating (**Figure 1**) ^[9]. As a result, the metal pastes (e.g., silver, gold, tungsten, and molybdenum) and resistor pastes can be cofired with the ceramic body to fabricate multilayer ceramic components. With the continuous development of electronic science and technology, the HTCC and LTCC processes are poorly suited to the rapid prototyping and low-cost manufacturing of miniaturized, thin, refined, and highly integrated functional ceramic devices.



Figure 1. Cofired ceramic process.

Three-dimensional printing is a breakthrough manufacturing method that can build 3D objects layer-by-layer from digital models and has developed rapidly since the 1980s. Three-dimensional printing is commonly known as additive manufacturing (AM), and the ASTM/ISO standard for AM classifies the different technologies into seven subcategories: material extrusion, material jetting, binder jetting, vat photopolymerization, powder bed fusion, direct energy deposition, and sheet object lamination ^[10]. According to this classification, HTCC and LTCC based on green tape lamination can also be considered an AM process, though different from 3D printing; therefore, to distinguish this concept, the researchers use the term "3D printing" rather than "AM".

In recent years, 3D printing has become a research focus in fine ceramic manufacturing, and it can be used to construct most structural ceramics ^{[11][12][13][14]}. However, functional ceramic devices with a composite structure comprising two or more materials usually contain strip lines, microstrip lines, and vias; as a result, in addition to enhancing the spatial resolution and printing speed, several problems in terms of the raw materials, printing strategies, and sintering process still need to be solved. Multi-material 3D printing of functional ceramic devices is in early development and has great research motivation and application potential ^{[15][16][17][18][19]}.

2. Multi-Material 3D Printing Methods

2.1. Material Jetting (MJ)

MJ derives from conventional 2D ink jetting extensively used in graphic fields (e.g., office documents, digital photos, labels, tiles, and clothing) ^[20]. In MJ, droplets of the feedstock material are selectively deposited and solidified in successive layers ^[21]. Several MJ techniques are recognized by the mechanism of droplet generation, in which the most widely used are inkjet printing (IJP), aerosol jet printing (AJP), and electrohydrodynamic inkjet printing (EHDP). Over the past few years, these MJ techniques have attracted interest in the on-demand fabrication of highly customizable electronics because of their abilities to precisely and smartly deliver high-resolution patterns with a diversified structure (<1 μ m) from design files in a non-contact manner. Multi-material 3D printing of supercapacitors ^[22], filters ^[23], tapered optical waveguides ^[24], solar cells ^[25], microsensors ^[26], flexible circuits ^[27], and high-density redistribution layers (RDLs) of silicon interposers ^[28] has been easily implemented by

following the same approach of conventional 2D ink jetting by sequential deposition of functional inks via an MJ system equipped with multiple jetting heads. **Table 1** lists several recently developed functional inks whose printing methods, applications, sintering or curing techniques, and electrical properties are summarized.

Types of Functional Inks	Printing Methods	Applications	Electrical Properties
	Sliver MNPs inks; IJP ^[29] , EHD ^[27]	Wearable electronics ^[27] [29]	0.08–4.74 Ω sq ⁻¹ after 1 h of thermal sintering at 150 °C ^[29] ; 0.4 Ω sq ⁻¹ after 30 min of thermal sintering at 250 °C ^[27]
Metal	Gold MNPs inks; IJP ^[30] , AJP ^[31]	Non-enzymatic electrochemical sensors ^[30] ; micro-hotplates ^[31]	0.06 Ω cm ⁻¹ after 30 min thermal sintering at 100 °C ^[30] ; 8.7 ± 2.5 µ Ω cm after 1 h of thermal sintering at 120 °C followed by 250 °C for 4 h ^[31]
nanoparticles (MNPs) inks	Copper MNPs inks; IJP ^[32] , EHD ^[33]	Conductive patterns and tracks ^[32] ; micro- electronic devices ^[33]	6.18 Ω sq ⁻¹ after applying 5454 J energy ^[32] ; 9.20 μΩ cm after 1 h of thermal sintering at 230 °C in inert atmosphere ^[33]
	Zinc MNPs inks; IJP ^[34] , AJP ^[35]	Flexible electronics ^[34] ; bioresorbable electronics [35]	~10 ² S cm ⁻¹ ^[34] ; 22.32 S cm ⁻¹ was achieved after 2 ms of sintering by 1 flash with energy of 25.88 J/cm ² , and the final conductivity of 34.72 S cm ⁻¹ was achieved by an optimum laser power ^[35]
Conductive	PEDOT: PSS inks; IJP ^[36] , AJP [<u>37</u>]	Organic solar cells [<u>36</u>]; µ- needle electrode arrays [<u>37</u>]	0.02 S cm ⁻¹ after 20 min of thermal annealing at 120 °C (120 nm thick) ^[36] ; 0.323 ± 0.075 S cm ⁻¹ ^[37]
polymer inks	BBL: PEI inks; Spray-coating ^[38]	Organic electrochemical transistors and bioelectronics ^[38]	8 S cm ⁻¹ after 2 h of thermal annealing at 140 °C inside a nitrogen-filled glovebox [<u>38</u>]

Table 1. Summary of recently developed functional inks.

Types of Functional Inks	Printing Methods	Applications	Electrical Properties
Ceramic nanoparticle (CNP) inks	Al ₂ O ₃ CNPs inks; IJP ^[39]	Thin film radio-frequency capacitors ^[39]	The dielectric constant of the printed alumina layer (~120 nm thick with ~0.5 nm RMS surface roughness after the thermal annealing at 400 °C) was 6.2 ^[39]
	BaTiO ₃ CNPs inks; IJP ^[40] , AJP [<u>41</u>]	Piezoelectric generators ^[40] ; interdigitated capacitors ^[41]	The piezoelectric generator had an open- circuit voltage of ~7 V, a current density of $0.21 \ \mu A \cdot cm^{-2}$, and a power density of $0.42 \ \mu W \cdot cm^{-2}$ [40]; the dielectric constant was 7 [41]
	3Y-TZP CNPs inks; IJP ^{[42][43]}	Dielectric films for microelectronic devices [42][43]	1
	ZrO ₂ CNPs inks; IJP ^[44] , EHD ^[45]	Dielectric layers for flexible electronics ^[44] ; resistive switches ^[45]	The ZrO ₂ dielectric film (dielectric constant of 10) afforded a leakage current density of 5.4×10^{-6} A/cm ² at 1 MV/cm ^[44] . The printed resistive switch showed stable bipolar memristive switching behavior around ± 3 V ^[45]
	TiO ₂ CNPs inks; IJP ^{[<u>46][47]</u>}	Mesoporous TiO ₂ electron transport layers for perovskite solar cells ^[46] ; dielectric layers ^[47]	The perovskite solar cell had a power conversion efficiency of 18.29% ^[46] ; the current-voltage characteristics of conducting oxide-TiO ₂ -Ag devices showed diode behavior ^[47]
	Ba _{0.6} Sr _{0.4} TiO ₃ CNPs inks; IJP [<u>48]</u>	Dielectric layers for capacitors ^[48]	The relative dielectric constant was 28 ± 1.7, and the dielectric loss was 0.043 ± 0.006 (at 10 kHz) ^[48]

Types of Functional Inks	Printing Methods	Applications	Electrical Properties	
	Ca ₂ Nb ₃ O ₁₀ CNPs inks; AJP [49]	Thin-film transistors ^[49]	The films deposited by Ca ₂ Nb ₃ O ₁₀ ink with a mass fraction of 82 wt% showed a dielectric constant of 8.5 and a dielectric loss of 0.058 (at 1 MHz) ^[49]	
	Glass silicate CNPs inks; IJP [50]	Multilayer hybrid circuits [50]	/	
	Polyimide (PI) inks; IJP ^[51]	Capacitors for microelectronic devices [51]	The printed capacitor with 25 \pm 0.2 μm thick PI layer showed a capacitance value of 103 pF $^{[51]}$	
Dielectric polymer inks	Poly 4- vinylphenol (PVP) inks; IJP [52]	Flexible capacitors for wearable electronics ^[52]	The printed capacitor with 4.5 μm thick PVP layer showed a capacitance value of 163 pF ^[52]	;; 1SO,
	Polyvinyl alcohol (PVA) inks; EHD [<mark>53</mark>]	Gate insulators in organic field-effect transistors ^[53]	The organic field-effect transistors with PVA-based gate insulators show stable operation with low gate leakage currents [53]	viror g. 20

20, 44-00.

4. Thelemann, T.; Bartnitzek, T.; Suphan, K.-H.; Apel, S. Advancing packaging solutions using 3D capabilities of ceramic multilayers. In Proceedings of the 2015 European Microelectronics

2.2. Directoric (DWC), Friedrichshafen, Germany, 14–16 September 2015; pp. 1–6.

5. Oshima, S.; Wada, K.; Murata, R.; Shimakata, Y. Multilayer Dual-Band Bandpass Filter in Low-DIW originated from robocasting technology, which was initially established by Cesarani et al. at Sandia National Temperature Co-Fired Ceramic Substrate for Ultra-Wideband Applications. IEEE Trans. Microw. Laboratories in 1997. As an extrusion-based versatile 3D printing method, DIW provides a powerful route for Theory Tech. 2010, 58, 614–623.
fabricating complex 3D structures with high aspect ratio walls or spanning elements at the meso- and microscale forhibolizmid a domain of the part 8. Bhutani, A.; Gottel, B.; Lipp, A.; Zwick, T. Packaging Solution Based on Low-Temperature Cofired Ceramic Technology for Frequencies Beyond 100 GHz. IEEE Trans. Compon. Packag. Manuf.



Gong, P.; Li, Y.; Xin, C.; Chen, Q.; Hao, L.; Sun, Q.; Li, Z. Multimaterial 3D-printing barium titanate/carbonyl iron composites with bilayer-gradient honeycomb structure for adjustable. Figure 2. (a) Schematics of plunger-based extrusion, pneumatic-based extrusion, and screw-based extrusion of broadband microwave absorption. Ceram. Int. 2021, 48, 9873–9881. DIW. (b) Cross sectional view of the UV-assisted DIW process (c) Multi-material 3D printing with a dual nozzle 19\Structure. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (b) Cross sectional Screw-based extrusion of broadband microwave absorption. Ceram. Int. 2021, 48, 9873–9881. DIW. (b) Cross sectional view of the UV-assisted DIW process (c) Multi-material 3D printing with a dual nozzle 19\Structure. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (b) Cross sectional Screw-based extrustor. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (b) Cross sectional Screw-based extrustor. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (b) Cross sectional Screw-based extrustor. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (b) Cross sectional Screw-based extrustor. (c) Multi-material 3D printing with a dual nozzle 19\Structure. (c) Multi-material 3D printing with a dual nozzle 20. Castrejon-Pita. (c) Structure. (c) Multi-material 3D printing continuous change in the fluorescent pigment concentration [65]. (f) Optical image and schematic illustration of the multicore-shell nozzle 20. Castrejon-Pita, J.R.; Baxter, W.; Morgan, J.; Temple, S.; Martin, G.; Hutchings, I.M. Future, opportunities and challenges of inkjet technologies. At. Sprays 2013, 23, 541–565.

20 an Did ang d Ig 60 becore, inter Sce Babensael, 6 kAsy Dessign for mouth neated additions, rated (gig chosing each time emages of the dimension taken and the structure of 167-174. Various material and process parameters, for instance, the rheological properties of the ink (e.g., viscosity and 22. Choi, K.-H.; Yoo, J.; Lee, C.K.; Lee, S.-Y. All-inkjet-printed, solid-state flexible supercapacitors on surface tension), the geometric features of the nozzle, extrusion pressure, standoff distance, printing speed, strip paper. Energy Environ. Sci. 2016, 9, 2812–2821. spacing, and curing technique, significantly dictate the quality (e.g., dimensional error, surface roughness, layer 2Bat Cesst can dMnTerf Sciao skienlyth Pietkaezprint Grosz pzyte 921,669.; SAViercz æsken fRapateo by roter calified Realization inclofteuthe 3Dilpyinteld Websilyd bang passrfitzers wisingsabjeased jet apsintar of dech softigion the Prosteer dimension extrafstore, 201.8e418thpEontapietanTMetrearvaerecounteners pestiEuelly Contraladdoyi Epainsi 25o276 September ough smale1.8pppe1.0103+dE0116her feature resolution, they sacrifice build efficiency, and a greater extrusion pressure is required to enable smooth flow of the viscoelastic ink at the risk of nozzle damage. Notably, DIW with a nozzle 24. Theiler, P.M.; Lutolf, F.; Ferrini, R. Non-contact printing of optical waveguides using capillary diameter ranging from 0.5 μm to 5 μm has been used to create structures with feature sizes ranging from 100 nm bridges. Opt. Express 2018, 26, 11934–11939. to 10 μm ^[69]. 25. Eggenhuisen, T.M.; Galagan, Y.; Biezemans, A.F.K.V.; Slaats, T.M.W.L.; Voorthuijzen, W.P.; The Keramenene of the Shastrategies a satisfied in the stemate of a standing with the Wees with the trade of the the temperature of the standard of the temperature of the standard of the sta the efficiency estight and jet to entredior gable solar cells is with a free digne of the estimated Jada at the ine in 2011 by a later of the solar of the entremedian of the solar of the entremedian of the estimated of the syridge 255 - 726 20 multiple nozzles to construct multi-material structures layer-by-layer (Figure 2c) [70]. This strategy is the most commonly used and involves switching between multiple nozzles for sequential 26. Qin, H.; Dong, J.; Lee, Y.-S. Fabrication and electrical characterization of multi-layer capacitive printing, which requires accurate coordination of each nozzle and careful flow control of viscoelastic inks, especially touch sensors on flexible substrates by additive e-jet printing. J. Manuf. Process. 2017, 28, 479– when the printed inks have different rheological properties [71]. The second uses a single nozzle with the capability 485. of switching between inks or in situ mixing of multiple inks via a mixing impeller driven by rotary motor during the 27rinKihaprocessahinasimKitaAliousivKhatolisig Wappinted, Bernark, (Arguaberationeroticie with by any in makes it possible electrolaxel polytomatic inkies or batting for the polytometer apple electronics strended end of the polytomatic inkies or batting for the polytometer apple electronics strended end of the polytomatic inkies of the polytometer apple electronics and exp375/0n,3570 permittivity). The third strategy uses a multicore-shell nozzle with several specific inputs connected 278. Operation of the second o g) Fabrication of Multilayer High-Density RDL of Silicon Interposer. IEEE Trans. Electron Devices 2017, 64, 1217-1224. Recently, multi-material DIW has been increasingly adopted to manufacture functionally graded structures (e.g., 29bKatel Michard Geberato Tansse Nova and our Kersap Leates 2826, All the state of the Gataples not Silver to bard 1801, CAM BOSTIGAUNELOND JEXTILES FOR HIGHLY SANDLUCIVE WEAN AD SMELER FLODICS AND LIESTING STAR INKS. For²example,⁸935, et al. ^[81] used a multi-material DIW printer to fabricate a scaffold with a poly(ε-caprolactone) 30. CK2 Af, poly Safricas, R. (PLA) ashall and Devropale real hearante dimeters rulate (REDMA) interarchisel arabitecture. The nedelition of the all sensor Puths about of the analysis of the sense of the sources of the sense of the strength Nature bone tissue comprises hierarchical porous structures that support cell growth, provide space for

nutrient transport, and withstand different types of ambient loads ^[82]. Critical size or non-union bone defects can be 31. Khan, S.: Nguyen, T.: Lubei, M.: Thiery, L.: Vairac, P.: Briand, D. Low-power printed microtreated by surgically implanting biocompatible bone graft substitutes hotplates through aerosol jetting of gold on thin polyimide membranes. Microelectron, Eng. 2018, long-term use of biocompatible bone graft substitutes, such as displacement, allergic reaction, and the need for 194. 71–78, secondary surgery ^[84]. Another permanent solution is to facilitate bone tissue regeneration via a scaffold. Multi-32ateinal BIWDecealMerederaisglePable, Alignational decealed and the method of biotecompatible bone graft substitutes. In addition, anicomppierstmkcture maging Sciallectmotiplastes are substituted bone tissue to the substitutes. In addition, 33 pk/harrio4ic Rahimansk/fak/en(TPMS); 6 dautolks Hall Direct prietise geooppier could ustione raiscro-trauksrbany physicali-crozzabeeisectroleyodrodyacerrice volkiee prantingopeosies, selasticateorp Pricese and Teobrodh 200rs) 212, be con7/00ed7 99.

. Maiee, S.; Karlsson, M.C.F.; Woicik, P.J.; Sawatdee, A.; Mulla, M.Y.; Alvi, N.U.H.; Dyreklev, P.; **3. Fused Deposition Modeling (FDM)** Beni, V.; Nilsson, D. Low temperature chemical sintering of inkjet-printed Zn nanoparticles for FDMighlyreooolureivrolexiklenslervrogie companyngtseeniifles fflestraner29210t5re32(e.g., polylactic acid, 39.14 Mianajastyrene.; Polycarbo Bates Holyawiderupokysterene nance pokyethyle man H., Frause, ok. itaeinosopensive apparatus cast aph easy impletentation of FRMs is also known as two after the prication of FE is in this drocess, the the manufacturing. Science in the selectively softened in a liquefier head, and then the polymer is selectively extruded by the action of two counter rotating elements on the platform to build the 3D objects in a layer-on-layer 36. Singh A., Kativar, M., Garg A. Understanding the formation of PEDOT:PSS films by ink-jet manner. Over the past few years, thermoplastic polymer filaments reinforced by a variety of fillers, such as metals Ball Brinting for or or an in the second sec 37e. gzipmesha@cob,strengthklinhePnaTeckadudkivitAdlgennikivitWeißelectrik. idvasvencD.bivvoninatibilBy)Foflythese confronteed EDA control confront and the second and

and App the poly where r. Interfaces 2019, 11, 32778-32786.

38. Yang, C.-Y.: Stoeckel, M.-A.; Ruoko, T.-P.; Wu, H.-Y.; Liu, X.: Kolhe, N.B.; Wu, Z.: Puttisong, Y.; The critical parameters of FDM are filament-specific (e.g., thermal, mechanical, and rheological properties and Musumeci, C. Massetti, M.; et al. A high-conductivity n-type polymeric ink for printed electronics, diameter), operation-specific (e.g., temperature, speed, and structure of 3D-printed object), and apparatus-specific Nat. Commun. 2021, 12, 2354. (e.g., number of extrusion heads, nozzle diameter, and gear force) [97][98]. Multi-material 3D printing with FDM 399. Wioketerich ED (2); talaller, essil Monalemeated vus Mollachilater, extrasios hanaites. Aand kilee-pretted the film wh incleasiogrietquest cy overexits revealed and issay of the private and the distinct of the second stated on t con99846-s9850 res, such as low resolution accompanied by poor surface finish, insufficient bonding between adjacent sections, and slow build velocity ^[71]. Additionally, thermoplastic polymer filaments with high solid content 40. Lim, J.; Jung, H.; Baek, C.; Hwang, G.-T.; Ryu, J.; Yoon, D.; Yoo, J.; Park, K.-I.; Kim, J.H. All-are necessary for the fabrication of metal and ceramic parts because of the low shrinkage after sintering; However, inkjet-printed flexible piezoelectric generator made of solvent evaporation assisted BaTiO3 hybrid the dramatic increase in stiffness and brittleness adversely affects the production and printing process ^[99]. material. Nano Energy 2017, 41, 337–343. Therefore, significant efforts should be devoted to overcoming these challenges.

41. Craton, M.T.; He, Y.; Roch, A.; Chahal, P.; Papapolymerou, J. Additively manufactured

2.4 ht Vatio Reproportion of the 2019 titanate nanocomposite inks. In Proceedings of the 2019

49th European Microwave Conference (EuMC), Paris, France, 1–3 October 2019; pp. 488–491. In the vat photopolymerization (VP) process, a liquid-state photopolymer material housed in a vat is selectively 42. Rabul Sattemed ubramanianted process to fabricate thick (SLA), two-photon Httrography (2PL) or two-photon polymerization (2PP), digital light processing (DLP), and

439.10246415 Higuidviaterface. Moderation (G, IR); Deluca, M.; Ebert, J.; Danzer, R.; Telle, R. Mechanical

characterisation of miniaturised direct inkjet printed 3Y-TZP specimens for microelectronic

As one of the oldest VP technologies established by Hull in 1984, SLA uses a UV laser beam scanning quickly applications. J. Eur. Ceram. Soc. 2010, 30, 3145-3152. along a controlled path to cure the irradiated photopolymer material within a vat from point to point. After one slice

48. Finited, the build platform moves Ningen Hard Bi, 1145; (Webending bonuf the Machine Isua Kop-dema, of Bottom-up structure) with a constant answhere the indrepactly Brenand Richtless High Performance Metal Oxide printing until the stric Eilms at Low Temperature, ACS Applia Mater Interfaces 2019, 11, 51, 93-51, 99. conventional

- 4(singlequisoth) Stkinby HeQtoDog, the Hty Choot the Htz CQ2 of existence sector structures with the photopolyghee heat construction of the transformation of the transformat
- 47. Padrón-Hernández, W.; Ceballos-Chuc, M.C.; Pourjafari, D.; Oskam, G.; Tinoco, J.C.; Martínez-
- In dooperst, the state of the second second
- surface of the photopolymer material within a vat. DLP considerably improves building efficiency because any 48. Mikolajek, M.; Friederich, A.; Kohler, C.; Rösen, M.; Rathjen, A.; Krüger, K.; Binder, J.R. Direct design can be printed layer-by-layer instead of individually addressing one voxel. Projection micro Infect Printing of Dielectric Ceramic/Polymer Composite Thick Films. Adv. Eng. Mater. 2015, 17, stereolithography (PµSL) is a development from DLP using a liquid crystal display, a digital micromirror device, or 1294–1301.
 liquid crystals on the silicon device as a dynamic mask and featuring superior resolution (up to 0.6 µm) ^[103]. CLIP 49. Adviner. development from DLP using a liquid crystal display, a digital micromirror device, or 1294–1301.
 stereolithography (PµSL) is a development from DLP using a liquid crystal display, a digital micromirror device, or 1294–1301.
 liquid crystals on the silicon device as a dynamic mask and featuring superior resolution (up to 0.6 µm) ^[103]. CLIP 49. Adviner. development from Z DLS¹⁰ erabling is cartifulated grave grav
- inhibiting free sacies and an and an and a second strategy of the pulled of the pulled
- 574n Zeang-baseTusk, Sinthagelen Biogles Nav SalehvrEgielat Kotstulapase Roor Wildmanors, runkist priutingdic devotes of xinaidea insulators for the the printing of distant is materials for initia patients in a second s throughout, and FDM [106]. However, most studies 52. mply Loc 45 rah, single enablerial. fabrilation. And an ultiking the right and resulting with a kito base a technologies or a mains challenging and bineted because of idifficulties in exchanging diquids state poeteog was on aterials within a watering general three sliferent strategies have been developed: (1) a hybrid process via the combination with DIW, AJP, or other special techniques, (2) vat switching, and (3) dynamic fluidic control. Among a few recently reported 53. Jung, C.; Tang, X.; Kwon, H.-J.; Wang, R.; Oh, S.M.; Ye, H.; Jeong, Y.R.; Jeong, Y.J.; Kim, S.H. applications, the first strategy may be the most straightforward and widely adopted. Lopes et al. in presented a Electrohydrodynamic-Printed Polyvinyl Alcohol-Based Gate Insulators for Organic Integrated hybrid multi-material 3D printing system that integrated SLA and DIW to tabricate monolithic structures with Devices. Adv. Eng. Mater. 2022, 24, 2100900. embedded circuits. SLA was used to build substrate structures, reserving the required receptacles into which 521e Hillonie son Apenalonie Priscove A. Du Diegoleintly writiente of and considering of and considering the second of the secon province thinge set and in the terminest conductioner near other shares and vertical vias to realize interconnection (Figure 3a). Similarly, Peng et al. ^[108] presented a hybrid multi-material 3D printing system that integrated DLP and 55. Gu, S.; Tian, Y.; Liang, K.; Ji, Y. Chitin nanocrystals assisted 3D printing of polycitrate thermoset DIW to fabricate active soft robots, circuit-embedding architectures, and strain sensors (Figure 3b–d). This bioelastomers. Carbohydr. Polym. 2021, 256, 117549. strategy requires an effective cleaning tool (e.g., air jet, vacuum, brush, and ultrasonic) to remove the uncured 56ndWablgmBr, hatdriaWangreGervee, receptercites, Xuan Brend, Utin neterical Additive Manutaraucing antihate feads to Matrixianal Silverin Gobel untaristifier 320 Geranaie of least on inside the Mater. Technol. 12082 or a 2160 12462 IIV 57. Jiang, Q., Yang, D., Yuang, H., Wang, R., Hao, M., Ren, W.; Shao, G., Wang, H., Cui, J., Hu, J. time consumption. To overcome this issue, researchers have proposed multi-material stereolithography without Sintering. Ceram. Int. 2021, 48, 32-41.

58/skm sO¹¹ Quinnun bebabalsytridge T¹²⁷¹⁴²¹¹⁴²¹¹⁴² (FigErsepseanoch & distributerset and the intervention of the set of

- 62. Lewis, J.A. Direct ink writing of 3D functional materials. Adv. Funct. Mater. 2006, 16, 2193–2204.
- 63. Tu, R.; Sodano, H.A. Additive manufacturing of high-performance vinyl ester resin via direct ink writing with UV-thermal dual curing. Addit. Manuf. 2021, 46, 102180.
- 64. Li, L.; Lin, Q.; Tang, M.; Duncan, A.J.; Ke, C. Advanced polymer designs for direct-ink-write 3D printing. Chemistry 2019, 25, 10768–10781.
- 65. Ober, T.J.; Foresti, D.; Lewis, J.A. Active mixing of complex fluids at the microscale. Proc. Natl. Acad. Sci. USA 2015, 112, 12293–12298.
- 66. Mueller, J.; Raney, J.R.; Shea, K.; Lewis, J.A. Architected Lattices with High Stiffness and Toughness via Multicore–Shell 3D Printing. Adv. Mater. 2018, 30, e1705001.
- 67. Ahammed, S.R.; Praveen, A.S. Optimization parameters effects on electrical conductivity of 3D printed circuits fabricated by direct ink writing method using functionalized multiwalled carbon nanotubes and polyvinyl alcohol conductive ink. Int. J. Simul. Multidiscip. Des. Optim. 2021, 12, 7.
- 68. Udofia, E.N.; Zhou, W. Microextrusion based 3D printing—A review. In Proceedings of the 2018 International Solid Freeform Fabrication Symposium, Austin, TX, USA, 13–15 August 2018.
- 69. Xu, M.; Lewis, J.A. Phase Behavior and Rheological Properties of Polyamine-Rich Complexes for Direct-Write Assembly. Langmuir 2007, 23, 12752–12759.
- 70. Sun, K.; Wei, T.-S.; Ahn, B.Y.; Seo, J.Y.; Dillon, S.J.; Lewis, J.A. 3D Printing of Interdigitated Li-Ion Microbattery Architectures. Adv. Mater. 2013, 25, 4539–4543.
- 71. Han, D.; Lee, H. Recent advances in multi-material additive manufacturing: Methods and applications. Curr. Opin. Chem. Eng. 2020, 28, 158–166.
- 72. Golobic, A.M.; Durban, M.D.; Fisher, S.E.; Grapes, M.; Ortega, J.M.; Spadaccini, C.M.; Duoss, E.B.; Gash, A.E.; Sullivan, K.T. Active Mixing of Reactive Materials for 3D Printing. Adv. Eng.



regeneration. Bio-Design Manuf. 2020, 3, 15-29.

Figure 3. Multi-material 3D printing with VP-based technologies. (a) Schematic illustration of the multi-material 3D 85. Betancourt, N.: Chen, X. Review of extrusion-based multi-material bioprinting processes, printing system integrating SLA and DIW. (b) Photographs of the printed electronic structure with an embedded 3D Bioprinting 2022, 25, e00189. helix, (c) photographs of the printed cylindrical lattice with three rings embedded, and (d) photographs of the

Schexploicationstation (198), (e) Koneexadia an optimistration Sf; tSee haltiana; Sial Pstoneolphagtuph, P. Wessignvats [115]. (f) Schexploicationstation printed triply particular instances and provide the printed triply particular instances and provide the printed triply particular instances (117]. (h) Schematic illustration of the multi-material PuSL system using dynamic fluidic control to rapidly fill and exchange multiple photopolymer 87. Boparai, K.S.; Singh, R.; Singh, H. Development of rapid tooling using fused deposition modeling: materials, and (i) photographs of the printed micro 3D structures (119). A review. Rapid Prototyp. J. 2016, 22, 281–299.

88. Ryder, M.A.: Lados, D.A.: Jannacchione, G.S.: Peterson, A.M. Fabrication and properties of novel **3. Applications of Multi-Material 3D Printing in Functional** polymer-metal composites using fused deposition modeling. Compos. Sci. Technol. 2018, 158, **Ceramic Devices** 43–50.

89. MARELARGES., FURCE JOBALE 9. ANIO 604 VICES WITH UNH HIP RECEIPTING ON SETURATE HARE HARE HIP BURGED IN THE PROVIDENCE INTO THE PROVIDENCE I

(ceramics, polymers, and metals) and their compatibility with 3D printing techniques must be further investigated. 90. Castles, F.; Isakov, D.; Lui, A.; Lei, Q.; Dancer, C.; Wang, Y.; Janurudin, J.; Speller, S.; Grovenor, **Table 2** lists several composition examples of multi-material 3D printing in functional ceramic devices. C.; Grant, P.S. Microwave dielectric characterisation of 3D-printed BaTiO3/ABS polymer

composites: Several composition examples of multi-material 3D printing in functional ceramic devices.

91. Wu. Y.: Isakov. D.: Grant. P.S. Fabrication of Composite Eilaments with High Dielectric Permittivity Multi-Material 3D

g	Compositions	Printing Techniques	Applications	Properties	Ref.	cations ⁻ ampa,
G	Dielectric material (ink): Ca ₂ NaNb ₄ O ₁₃ + Isopropanol + 2- butyl alcohol Electrode material (ink): Ag	IJP	Capacitors	The capacitor showed a capacitance density of ≈210 pF/mm ²	[120]	, B.; on of a
C) C)	Dielectric material (ink): Ba _{0.6} Sr _{0.4} TiO ₃ -ZnO-B ₂ O ₃ + Butyl diglycol + isopropyl alcohol + ethyl cellulose Electrode material (ink): Ag	IJP	Varactors	The varactors showed a tunability between 14.4% and 16.4% under a tuning field of 5 V/µm	[<u>121]</u>	DM-3D printing 07147. Polymer-
ç	Dielectric material (ink): MgTiO ₃ Electrode material (ink): Ag	IJP	Capacitors	1	[<u>122</u>]	ling 3D
	printing in phannaceutical applications. where are we now : Auv. drug deity. Rev. 2021, 175,					

113810.

C) C)	Compositions	Multi-Material 3D Printing Techniques	Applications	Properties	Ref.	ocess 3. ukla, C.;
10	Dielectric material (ink): Pb _{0.97} La _{0.02} Zr _{0.53} Ti _{0.47} O ₃ + ethylene glycol + ethanolamine Electrode material (ink): Ag	IJP	Capacitors	1	[<u>123</u>]	D19, Vat of 3D
10	Dielectric material (ink): Ba _{0.6} Sr _{0.4} TiO ₃ + Poly (ethylene glycol) diacrylate Electrode material (ink): Ag	IJP	Multilayer ceramic capacitors	The multilayer ceramic capacitors showed a capacitance density of ≈ 500 pF/mm ²	[<u>124]</u>	ced 4,
10	Dielectric material (ink): BaO-Al ₂ O ₃ - SiO ₂ -MnO-TiO ₂ Electrode material (ink): Cu	IJP	Multilayer ceramic substrates	The multilayer ceramic substrate showed a shrinkage ratio of ≈15%	[125]	ion
10 10	Dielectric material (ink): BaTiO ₃ Electrode material (/): Cu	AJP + etching + sputtering + plating	Multilayer ceramic substrates	The multilayer ceramic substrate showed a permittivity of ≈ 3000 and a dielectric loss of ≈ 7% at 1 MHz	[126]	ion by on 3D er.
1C 1C	Dielectric material (slurry): Al ₂ O ₃ Electrode material (slurry): tungsten	SLA + DIW	Multilayer ceramic substrates	The multilayer ceramic substrates showed a Young modulus E of ≈ 280 ± 11 GPa	[<u>127</u>]	3. al light
10	Dielectric material (ink): ZrO ₂ Electrode material (ink): Ag	IJP + AJP	Microstrip antennas	The bulk ZrO ₂ showed a relative permittivity of 23 and	[<u>128</u>]	s. Addit. /lanuf.

110. Choi, J.-W.; Kim, H.-C.; Wicker, R. Multi-material stereolithography. J. Mater. Process. Technol. 2011, 211, 318–328.

11 11	Compositions	Multi-Material 3D Printing Techniques	Applications	Properties	Ref.	ng with
11				a loss tangent of 0.0013 at microwave frequencies		aser
11	Dielectric material (ink): SiO ₂ + hexanediol diacrylate (HDDA) + alkyl-diphenyl oxide disulfonate Electrode material (ink): Cu	IJP	Microstrip antennas	The resistance was 2.43 × 10 ¹³ Ω·cm (174.3 μm thick dielectric layer)	[<u>129</u>]	D Print. edded Vater.
11	Dielectric material (filament): TiO ₂ + cyclo-olefin polymer (COP) Electrode material (slurry): Ag	FDM + DIW	Microstrip antennas	The 30% loaded COP-TiO ₂ showed a relative permittivity of 4.56 and a loss tangent of 0.0016 after sintering at 1100 °C	[<u>130</u>]	ત્રી ١g-on-
11	Dielectric material (filament): NdTi0 ₃ + polydimethylsiloxane (PDMS) Electrode material (slurry): Ag	FDM + DIW	Microstrip antennas	The 25% loaded PDMS- NdTiO ₃ showed a permittivity of 9.22 and a loss tangent of 0.025 at frequencies up to 17 GHz	[<u>131</u>]	ilorable G.U.; erial
11 12	Dielectric material (filament): MgCaTi0 ₂ + PDMS Electrode material (slurry): Ag	FDM + DIW	Microstrip antennas	The 19.6 GHz microstrip antenna showed a return loss of 20 dB along with a 10% bandwidth	[<u>132</u>]	ro- Inkjet)402.

121. Friederich, A., Kohler, C., Mikialazar, M., Wiens, A., Jakoby, K., Bauer, W., Binder, J.K. Hikjet-Printed Metal-Insulator-Metal Capacitors for Tunable Microwave Applications. Int. J. Appl. Ceram. Technol. 2015, 12, E164–E173.

- 122. Dossou-Yovo, C.; Mougenot, M.; Beaudrouet, E.; Bessaudou, M.; Bernardin, N.; Charifi, F.; Coquet, C.; Borella, M.; Noguera, R.; Modes, C.; et al. Inkjet Printing Technology: A Novel Bottomup Approach for Multilayer Ceramic Components and High Definition Printed Electronic Devices. J. Microelectron. Electron. Packag. 2012, 9, 187–198.
- 123. Matavž, A.; Benčan, A.; Kovač, J.; Chung, C.-C.; Jones, J.L.; Trolier-McKinstry, S.; Malič, B.; Bobnar, V. Additive Manufacturing of Ferroelectric-Oxide Thin-Film Multilayer Devices. ACS Appl.

Mater. Interfaces 2019, 11, 45155–45160.

- 124. Reinheimer, T.; Azmi, R.; Binder, J.R. Polymerizable Ceramic Ink System for Thin Inkjet-Printed Dielectric Layers. ACS Appl. Mater. Interfaces 2019, 12, 2974–2982.
- 125. Hirao, T.; Hamada, S. Novel Multi-Material 3-Dimensional Low-Temperature Co-Fired Ceramic Base. IEEE Access 2019, 7, 12959–12963.
- 126. Imanaka, Y.; Amada, H.; Kumasaka, F.; Takahashi, N.; Yamasaki, T.; Ohfuchi, M.; Kaneta, C. Nanoparticulated Dense and Stress-Free Ceramic Thick Film for Material Integration. Adv. Eng. Mater. 2013, 15, 1129–1135.
- 127. Raynaud, J.; Pateloup, V.; Bernard, M.; Gourdonnaud, D.; Passerieux, D.; Cros, D.; Madrangeas, V.; Michaud, P.; Chartier, T. Hybridization of additive manufacturing processes to build ceramic/metal parts: Example of HTCC. J. Eur. Ceram. Soc. 2021, 41, 2023–2033.
- 128. Oh, Y.; Bharambe, V.; Mummareddy, B.; Martin, J.; McKnight, J.; Abraham, M.A.; Walker, J.M.; Rogers, K.; Conner, B.; Cortes, P.; et al. Microwave dielectric properties of zirconia fabricated using NanoParticle Jetting[™]. Addit. Manuf. 2019, 27, 586–594.
- 129. Lee, J.-Y.; Choi, C.-S.; Hwang, K.-T.; Han, K.-S.; Kim, J.-H.; Nahm, S.; Kim, B.-S. Optimization of Hybrid Ink Formulation and IPL Sintering Process for Ink-Jet 3D Printing. Nanomaterials 2021, 11, 1295.
- 130. Castro, J.; Rojas, E.; Ross, A.; Weller, T.; Wang, J. High-k and low-loss thermoplastic composites for Fused Deposition Modeling and their application to 3D-printed Ku-band antennas. In Proceedings of the 2016 IEEE MTT-S International Microwave Symposium (IMS), San Francisco, CA, USA, 22–27 May 2016; pp. 1–4.
- 131. Castro, J.; Rojas, E.; Weller, T.; Wang, J. High-k and low-loss polymer composites with co-fired Nd and Mg-Ca titanates for 3D RF and microwave printed devices: Fabrication and characterization. In Proceedings of the 2015 IEEE 16th Annual Wireless and Microwave Technology Conference (WAMICON), Cocoa Beach, FL, USA, 13–15 April 2015; pp. 1–5.
- 132. Castro, J.; Rojas-Nastrucci, E.A.; Ross, A.; Weller, T.M.; Wang, J. Fabrication, Modeling, and Application of Ceramic-Thermoplastic Composites for Fused Deposition Modeling of Microwave Components. IEEE Trans. Microw. Theory Tech. 2017, 65, 2073–2084.

Retrieved from https://encyclopedia.pub/entry/history/show/80185